



Il Rettore

- Having seen the Law n. 240 of 30.12.2010;
- Having seen the D.M. n. 226 of 14.12.2021;
- Having seen the Regulations for the PhD program of this University n. 3337 of 01.04.2022, with particular attention to the art. 7 that regulates the methods of appointment of the members of the Examination Board for admission to the PhD courses;
- Having seen the decree Prot. 43761 Of 22/02/2023 related to the call for admission to PhD: 38° ciclo ingr. 01/06/2023: BANDO DOTTORATO corso di INGEGNERIA DELL'INFORMAZIONE / INFORMATION TECHNOLOGY - WAFER-LEVEL CHARACTERIZATION OF DIELECTRIC LAYERS RELIABILITY FOR GALVANIC ISOLATION ;
- Having seen the minutes of the Faculty Board meeting on the 06/04/2023, appointing the members of the PhD Admissions Examination Board;

DECREES

The PhD Admissions Examination Board for the call for admission to the PhD in: 38° ciclo ingr. 01/06/2023: BANDO DOTTORATO corso di INGEGNERIA DELL'INFORMAZIONE / INFORMATION TECHNOLOGY - WAFER-LEVEL CHARACTERIZATION OF DIELECTRIC LAYERS RELIABILITY FOR GALVANIC ISOLATION is made up of:

Surname and name	Role
MORICHETTI FRANCESCO	Actual Members
NATALI DARIO ANDREA NICOLA	Actual Members
PELOSI GERARDO	Actual Members
FORMENTIN SIMONE	Actual Members
ARDAGNA DANILO	Actual Members

Il Rettore

Prof. Donatella Sciuto

Digital signature according to the Digital Administration Code